



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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U.S. Patent Application

Applicant:

Karl-Heinz SCHUSTER.

Serial No.:

09/847,658

Filed:

05/02/2001

For:

PROJECTION LENS, IN PARTICULAR )

FOR MICROLITHOGRAPHY

Examiner:

William C. Choi

Gerald T. Shekleton Reg. No. 27,466

) I hereby certify that this correspondence is being

) deposited with the United Postal Service as first
) class mail in an envelope addressed to: Box NON-

FEE AMENDMENT/Commissioner for Patents/ Washington, D.C. 20231, on **October 9, 2002**.

**RESPONSE TO RESTRICTION REQUIREMENT** 

Box NON-FEE AMENDMENT Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

The Office Action of September 24, 2002 has been carefully reviewed and the following is in response thereto.

## REMARKS

In the above-identified Office Action, the Examiner has required restriction between the Claims of Group I, Claims 1-7 and 19-39 and Group II Claims 8-18.

Applicant(s) hereby elects for prosecution, Group I, Claims 1-7 and 19-39.

Applicant(s) believes the Restriction Requirement to be improper insofar as the Claims of the device and the claims of the method are so interlinked as to require that searching be conducted in identical classes and accordingly, Applicant believes that the search and examination of the entire application can be made without serious burden. Therefore, pursuant to MPEP Section 803, the Examiner should examine the entire application on the merits.

Respectfully submitted,

By

Gerald T. Shekleton Registration No. 27,466

Dated: October 9, 2002 WELSH & KATZ, LTD.

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